## **Equipment Information Sheet**

# **Class 1 Photolithography Hot Plates**

Manager: Giovanni Sartorello 607-254-4853 Calls to staff phones will be automatically forwarded to Backup: Garry Bordonaro 607-254-4936

their cell phones during accessible hours. At other times leave a message or send them an email.

#### SAFETY

• Surfaces can be hot.

### **USAGE RESTRICTIONS**

• General photolithography training (online and in-person) is required to use this tool.

#### SCHEDULING/SIGN-UP RESTRICTIONS

Minimum Tool Time: 0 minutes

• A group may have no more than 2 hotplates in simultaneous operation.

## MATERIALS COMPATIBILITY CATEGORY

#### **Tool Category 5: Class A and B Metals and Compounds**

Allowed	Not Allowed
Tool category 1/1E, 2, 3, and 4 materials	
Silicon Based Substrates and Films	
III/V compound Semiconductors	
Glass Substrates	
PECVD and ALD Films	
Cured organics and baked Photoresist	
CNF Class A, B, and Refractory metals	
Exposed Gold, Silver, Copper	
Alkali and Alkaline Compounds	
Organic/Biology Molecules prepared- w/salt buffers	
High Vapor Pressure Materials (Mg, Ca, Zn)*	* Some tool restrictions on high vapor pressure materials may apply
Soft organic materials	

## High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

#### **Additional Material Restrictions and Exceptions**

- Class 1 materials only (most positive resist, nLOF, i-line and DUV materials, P-20 primer).
- The backside of all substrates must be inspected and cleaned prior to baking.
- No low temperature materials.

Last Updated: 03/21/2025